

In re Application of: Grimbergen, et al.

Serial No.: 09/667,362

Filed: 9/21/2000

For: REDUCING DEPOSITION OF PROCESS RESIDUE ON A

WINDOW OF A CHAMBER

Group Art Unit: 1763

Examiner: Unknown

Attorney Docket No.

2813.P1/USA/SILICON/JB

January 9, 2001

San Francisco, California

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, D.C. 20231

Sir/Madam:

Attached hereto are PTO-1449 forms listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and initialed copies of the forms be returned to the undersigned.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents Washington, D.C. 20231

Rowena Montova

__ Dated

9.2001

Under 37 C.F.R. § 1.97(b) (3), an Information Disclosure Statement shall be considered by the Office if filed before the mailing date of the first office action.

Therefore, it is believed that no fee is due for the filing of this Information Disclosure Statement. However, if any fee is due, the Commissioner is hereby authorized to charge payment of any such fees to Deposit Account No. 10-0258.

Also, if any Petition is required for the filing of this Information Disclosure Statement, such Petition is requested herein.

It should be noted that the word "prior" has been deleted from the form.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES A PROFESSIONAL CORPORATION

Date: 1/9/2001

By:

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Encl.

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